



In re application of:

Tzeng

Group Art Unit: 1762

Serial No: 09/501,114

Examiner: Wesley D. Markham

Filed: February 10, 2000

Docket No.: 220101-1010

For: Method of Plasma Enhanced  
Chemical Vapor Deposition  
of Diamond

PETITION AND FEE FOR EXTENSION OF TIME  
(37 CFR 1.136(a))

Commissioner of Patents  
Washington, D.C. 20231

Sir:

1. This is a petition for an extension of time to respond to the Office Action mailed **June 27, 2002** for a period of **One Month**.

2. Applicant is:

☒ a small entity

☐ verified statement attached

☐ other than small entity

☐ verified statement filed

3. Extension  
(Months)

Fee for other than  
Small Entity

Fee for  
Small Entity

☒ one month

\$ 110

\$ 55

☐ two months

\$ 400

\$ 200

☐ three months

\$ 920

\$ 460

☐ four months

\$1,440

\$ 720

☐ five months

\$1,960

\$ 980

**Fee: \$55.00**

4. A First Response with Amendments and Remarks

☒ is filed herewith ☐ has been filed.

5. Fee payment

☒ Attached is a check in the sum of **\$193.00**.

☐ Please Charge the fee of \$ \_\_\_\_\_ to Deposit Account No. \_\_\_\_\_. A duplicate of this petition is attached.

☐ A Credit Card Authorization, authorizing the amount of: \$ \_\_\_\_\_ is attached.

☐ Please charge Deposit Account No. 20-0778 for any additional charge required. The Commissioner is requested to credit any overpayment to Deposit Account No. \_\_\_\_\_.

THOMAS, KAYDEN, HORSTEMEYER & RISLEY, L.L.P.

Date: 10/4/02

Christopher B. Linder, Reg. No. 47,751  
Attorney for Applicant

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